

Docket No.: SON-2611/DIV  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Divisional Patent Application of:  
Keiichi Kimura et al.

Application No.: Not Yet Assigned

Confirmation No.: 6112

Filed: March 23, 2004

Art Unit: 3723

For: POLISHING METHOD AND POLISHING  
APPARATUS

Examiner: Hadi Shakeri

**CLAIM FOR PRIORITY**

MS Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Applicant hereby claims priority under 35 U.S.C. 119 based on the following prior foreign application filed in the following foreign country on the date indicated:

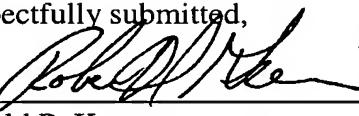
Country	Application No.	Date
Japan	2002-079163	March 20, 2002

In support of this claim, a certified copy of the said original foreign application was previously filed in prior application serial number 10/390,769.

Applicant believes no fee is due with this response. However, if a fee is due, please charge our Deposit Account No. 18-0013, under Order No. from which the undersigned is authorized to draw.

Dated: March 23, 2004

Respectfully submitted,

By   
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